Ultrafast chemical imaging by widefield photothermal sensing of infrared absorption

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Infrared (IR) imaging has become a viable tool for visualizing various chemical bonds in a specimen. The performance, however, is limited in terms of spatial resolution and imaging speed. Here, instead of measuring the loss of the IR beam, we use a pulsed visible light for high-throughput, widefield sensing of the transient photothermal effect induced by absorption of single mid-IR pulses. To extract these transient signals, we built a virtual lock-in camera synchronized to the visible probe and IR light pulses with precisely controlled delays, allowing submicrosecond temporal resolution determined by the probe pulse width. Our widefield photothermal sensing microscope enabled chemical imaging at a speed up to 1250 frames/s, with high spectral fidelity, while offering submicrometer spatial resolution. With the capability of imaging living cells and nanometer-scale polymer films, widefield photothermal microscopy opens a new way for high-throughput characterization of biological and material specimens.

INTRODUCTION

Vibrational imaging methods offer a new window to characterize samples based on spectroscopic signatures of chemical bonds. Raman and infrared (IR) spectroscopy have long been used to interrogate materials by probing molecular vibrations without exogenous labels. Spontaneous Raman microscopy offers submicrometer spatial resolution imaging capability but suffers from the low acquisition rates (1, 2). With the advent of coherent Raman scattering techniques, video-rate imaging speed has been demonstrated in the characterization of biological and pharmaceutical samples (3, 4). However, the extremely small Raman cross section (~10−30 cm2 sr−1) limits the detection sensitivity. On the other hand, the IR absorption offers a much larger cross section (~10−22 cm2 sr−1) that enables adequate sensitivity. Fourier transform IR (FTIR) spectrometer, together with its attenuated total reflection accessories, is the typical instrument of the technique and has been extensively used in the fields ranging from polymer science, pharmaceuticals, to biological research (5–7). Coupling focal plane array detectors to FTIR systems allows us to simultaneously acquire spatially resolved spectra, greatly improving the throughput for characterization of inhomogeneous samples (8). Unlike the conventional FTIR instrument based on interferometry and low-brightness globar excitation, discrete IR spectroscopic imaging techniques use tunable quantum cascade laser with much higher photon flux per wavenumber, which enables real-time IR imaging (9). Alternatively, up-conversion of mid-IR light to the visible region has also been demonstrated for hyperspectral IR imaging (10, 11). However, the long incident wavelengths in the mid-IR region determine the spatial resolution at several to tens of micrometers, which is not sufficient to resolve microstructures such as in biological cells.

Near-field scanning approach provides a way to surpass the fundamental limitation in resolution (12–15). Apertureless near-field scanning microscope combines atomic force microscopy (AFM) with IR spectroscopy (14, 15), where the AFM cantilever changes the oscillation amplitude due to the surface thermal expansion induced by the absorption of the mid-IR light. The spectra, at nanoscale localization, are obtained by recording the amplitude change while sweeping the wavelengths of the mid-IR light source. With the capability of providing high spatial resolution chemical mapping, AFM-IR has been a valuable tool to study block copolymer system where the domain size is typically tens of nanometers (16). Yet, this technique shares the inherent drawback of tip-based imaging modality of low acquisition speed. In addition, although some work showed the capability of investigating samples in aqueous environment using the total internal reflection of an IR prism to minimize the influence of water, sophisticated setup and data processing procedure make it unsuitable for routine use (17, 18).

In contrast, a noncontact probe, such as a visible laser, can reduce the limits on sample preparation and provide higher imaging speed. Recently, the Cheng group developed a mid-infrared photothermal (MIP) microscope using a visible laser to probe the IR absorption–induced thermal lensing effect in the sample, providing chemical imaging capability with submicrometer resolution and depth resolution (19), which fills the gap between FTIR and AFM-IR microscopy. When the IR wavelength is tuned to the absorption peak of the sample, the co-propagated probe beam will change its divergence due to the thermal-induced local refractive index change. Using this approach, chemically selective imaging of live cells and organisms was demonstrated (19, 20). For nontransparent samples, a backward-detected photothermal microscope was developed to allow chemical mapping of active pharmaceutical ingredients and excipients of drug tablets (21). Other groups have also implemented optical probing of IR absorption. Lee and Lee (22) reported optical IR imaging by using a 3.5-μm IR source produced through difference frequency generation between two near-IR beams. Furstenberg et al. (23) demonstrated photothermal imaging of materials using a visible laser probe. Erramilli and co-workers (24, 25) investigated the nonlinear photothermal phenomena causing spectral peak splitting at different phase states of liquid crystal. The Sander group demonstrated photothermal IR

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imaging of a thin polymer film with a spatial resolution of 3.1 μm (26) and reported photothermal IR imaging of mouse brain tissue slices targeting the protein amide I band, consistent with hematoxylin and eosin staining results (27). Recently, the Hartland and Kuno groups reported a counter-propagation scheme at a 300-nm resolution with chemical specificity and its application to characterize the perovskite-based solar cell (28, 29). In these pixel-by-pixel scanning implementations, the imaging speed is limited by the pixel dwell time needed to cover the photothermal decay process. In addition, focus mismatch between IR and visible beams that leads to only a small portion of IR photons was used. On the basis of speckle pattern and Mie scattering, widefield photothermal imaging has been demonstrated (30, 31), with a typical acquisition time of ~20 s for a field of view of 17 μm by 17 μm. In these previous studies, the low signal level due to the limited number of scattered photons hampers the imaging speed, and is insufficient for the study of living specimens or for high-throughput screening purpose.

Here, we demonstrate a widefield photothermal sensing (WPS) microscope that allows ultrafast chemical imaging at a speed up to 1250 frames/s. To enable high-throughput detection of IR absorption, a multi-element photodetector, such as a camera, is required. However, generic cameras are not fast enough to resolve the transient thermal process at the microsecond level, i.e., 1 million frames/s. To achieve high temporal resolution using regular cameras, time-gated detection using pulsed light was previously demonstrated for mapping electronic currents in integrated circuits (32, 33). Here, we borrow this concept and build a virtual lock-in camera, where the exposure frames are synchronized to the probe pulses and the IR pulses at the same repetition rate with precisely controlled time delays. Our method enables time-resolved imaging of the transient thermal process using a regular camera, with a temporal resolution determined by the probe pulse width.

Furthermore, to enable efficient delivery of the IR laser to the sample and reflection of the probe photons to the camera, we adopt widely available silicon wafers as the substrate for its transparency in the IR window and high reflectance of visible photons. The silicon substrate further enhances the photothermal sensing speed by accelerating the heat dissipation. Silicon has high thermal conductivity (150 W m⁻¹ K⁻¹) compared to other IR transparent materials such as CaF₂ (10 W m⁻¹ K⁻¹), which avoids heat accumulation and allows faster imaging. In addition, the pure scattering field is much enhanced through interference, where the reference field is provided by the silicon-reflected light. Collectively, these innovations enabled ultrafast detection of IR-induced photothermal signals in a widefield manner.

RESULTS

WPS microscope

The widefield photothermal imaging system is based on a widefield reflection microscope (Fig. 1; detailed in Materials and Methods). A pulsed blue light-emitting diode (LED) was used to illuminate the sample through a 4f lens system, a 50/50 beam splitter, and an objective. The light reflected from the sample was then collected by the same objective and beam splitter and recorded by a camera with a tube lens. The pump source was provided by a nanosecond-pulsed mid-IR laser, which was weakly focused into a sample through the silicon wafer. The counter-propagation beam configuration, as previously demonstrated by the Hartland and Kuno groups (28, 29), is adopted in our work, except that we used a pulsed widefield illumination instead of tight-focusing condition. A chopper was used to modulate the IR pulse train to accommodate the speed of the camera. The master clock of the system was provided by the IR laser, monitored with a mercury cadmium telluride (MCT) detector through a residual IR beam picked up from a CaF₂ plate.

Widefield measurement of transient thermal signal

To extract the transient photothermal signal, we developed a virtual lock-in camera synchronized to the IR laser repetition rate with precise delays of the probe pulse. By using a pulsed probe light, the temporal resolution of the system was determined by the pulse width of the probe light, which was around 900 ns. Figure 2A shows the block diagram of widefield detection. The master clock from the MCT was used to trigger the function generator, which sent square wave triggers to the camera, chopper, and LED. The time delay of the probe pulse relative to the pump pulse was controlled electronically by the function generator. The camera provides a frequency division function that enables exposing under 2500 Hz with a 20-kHz external trigger frequency. Furthermore, the optical chopper frequency was locked to the camera exposure period to ensure complete block of the IR pulses when necessary.

The actual pulse trains of pump and probe pulses relative to the camera exposure were measured and plotted in Fig. 2 (B and C). The camera exposure indicator is plotted in channel 3, with high voltage level representing the actual camera exposure period. Figure 2C shows a zoom-in image of the pump and probe delay. As a result, the IR pulses were chopped into bursts with as few as eight pulses during a camera exposure, recorded by the visible probe pulses with controlled delays. We define the images with mid-IR pulses as “hot” frames, and those without as “cold” frames. Therefore, the final data
became an image stack with alternating hot and cold frames. For the widefield scheme, all pixels within the field of view were recorded simultaneously. To extract the signal, each hot frame was subtracted by a subsequently recorded cold frame, and the subtraction results were integrated until a reasonable signal-to-noise ratio (SNR) was reached (Fig. 2D). Furthermore, the thermal decay profile can be mapped by scanning the pump-probe delays.

**Origin of contrast**

To explain the origin of the signal, we built a model based on interference and used thin-film samples as an example to illustrate the model. For a thin-film sample on top of the silicon substrate, there are two major reflections: the air-sample interface and the sample-substrate interface (fig. S1A). Together with the interference term and under near-normal incident approximation, the percentage of reflection $R$ at probe wavelength $\lambda$ can be described as (34)

$$R(\lambda) = \frac{r_1^2 + r_2^2 + 2r_1r_2 \cos(2k_0n_1(\lambda)d)}{1 + r_1^2r_2^2 + 2r_1r_2 \cos(2k_0n_1(\lambda)d)}$$

(1)

where $r_1(\lambda) = [n_0(\lambda) - n_1(\lambda)]/[n_0(\lambda) + n_1(\lambda)]$ and $r_2(\lambda) = [n_1(\lambda) - n_2(\lambda)]/[n_1(\lambda) + n_2(\lambda)]$ are reflections as a function of refractive index $n(\lambda)$ of the material at the two interfaces and $d$ is the thickness of the sample. The subscripts 0, 1, and 2 refer to the layer of air, sample, and the substrate, respectively. When the IR beam is absorbed by the sample, heat is produced and the maximum temperature increase can be described as $\Delta T \propto \sigma I_{IR}/pC$, where $\sigma$ is the absorption coefficient, $I_{IR}$ is the pump beam intensity, and $p$ and $C$ are the density and heat capacity of the sample, respectively (35). The temperature rise $\Delta T$ will induce a refractive index change and a thermal expansion of the sample:

$$n'_1(\lambda) = n_1(\lambda) + \alpha \Delta T$$

$$d' = d(1 + \beta \Delta T).$$

Here, $\alpha$ is the thermo-optic coefficient $dn/dT$ and $\beta$ is the coefficient of thermal expansion $(1/L)(dL/dT)$. The detected light $R(\lambda)$ at the hot state is acquired with the update of $n'_1(\lambda)$ and $d'$ in Eq. 1. After integrating all the probe wavelengths within the spectral width of the LED, the photothermal signal is derived by comparing the difference of $R'$ and $R$. We used the poly(methyl methacrylate) (PMMA) as an example for simulation. The reflection curve at the hot state was calculated with the material’s thermal properties (36) and showed together with the reflection at cold state (fig. S1B). The simulated reflection difference $(R' - R)/R$ for PMMA film thickness ranging from 0 to 500 nm was plotted in fig. S1C, where a strong etalon effect was observed. We performed experiments with selected film thickness, and the results matched well with the simulation results (fig. S1C). For particle samples, the detected light is from the interface reflection, particle scattering, and interference field. Because there is no closed-form equation, numerical simulation methods reported by Li et al. (28) should be used.

**Temporal resolution and chemical selectivity**

To characterize the temporal resolution, we performed time-resolved WPS imaging of 486-nm-thick PMMA film on silicon substrate. The IR pump was tuned to 1728 cm$^{-1}$ (the C=O absorption peak in PMMA). The probe width was around 914 ns, and each image was acquired at a speed of 2 Hz. The probe power at sample was around 1.6 mW, limited by the full well capacity of the camera. Estimation of maximum probe power saturating the camera sensor is provided in the Supplementary Materials. The pump power at the sample was around 5.1 mW. By subtracting the cold frames by the hot frames, i.e., contrast reversed for better visualization, WPS imaging at various pump-probe delays was acquired (Fig. 3A). The bright spot in the center of the field of view corresponded to the weakly focused

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**Fig. 2. Camera-based photothermal imaging. (A) Block diagram. The MCT detector was used to capture the IR laser pulses to generate the master clock $f$ at the repetition rate of the IR laser to trigger the function generator, which sent square wave triggers to the camera, chopper, and LED. The internal frequency divider of the camera was set to expose at $f/8$ frames/s. The chopper divided the trigger pulses by 16 to modulate the pump. A computer was used to control the camera and store the data. (B) Measured pulses of the IR (red), visible (blue), and camera exposure monitor (purple) with an oscilloscope. For the 20-kHz laser repetition rate and 2500-Hz camera frame rate, each frame contained eight probe pulses. (C) Zoom-in view of individual pump and probe pulses. The time scale for each grid is 100 ns. (D) Image processing procedure to generate a photothermal image. Contrast was created by subtraction between hot and cold frames. Scale bars, 40 μm.
IR spot. The signal intensity at the center of each image was used to plot the temporal profile of photothermal signal, with time delay ranging from $-0.97$ to $3.89 \mu$s (Fig. 3B). The video of the decay can be found in movie S1. The data points were well fitted into an exponential decay $e^{-t/\tau}$, where $t$ is the time delay and $\tau = 1.1 \mu$s is the decay constant, indicating a fast cooling time. Note that the decay constants should not be confused with temporal resolution, which is determined by the probe pulse width, i.e., 914 ns, in our system.

We further demonstrated the spectral fidelity of our WPS microscope. We tuned the pump wavelengths at the time delay where the WPS signal was maximized. The raw spectrum was normalized by the pump power (Fig. 3C). The black curve was the reference FTIR spectrum measured with a commercialized FTIR spectrometer (VERTEX 70v, Bruker). A good agreement was obtained between the WPS signal in terms of photoelectron counts and the standard FTIR spectrum.

**Submicrometer spatial resolution**

To evaluate the spatial resolution, WPS imaging of polymer film patterns and beads was performed (Fig. 4). The “MIP” letters were etched off a PMMA film around 310 nm thick using electron-beam lithography, and the bare silicon showed higher reflectivity compared to the remaining areas. The widefield reflection image is shown in Fig. 4A. The letter “I” was 2 μm in width and 10 μm in length. The WPS imaging of the pattern was acquired within 0.5 s with a cold frame minus a hot frame, showing clear contrast at the etching boundaries (Fig. 4B). The intensity profile along the line was extracted, as indicated in Fig. 4B. Nine adjacent lines were averaged to perform the first derivative (Fig. 4C). The theoretical value for optical resolution with 0.66–numerical aperture (NA) objective and 450-nm illumination is calculated to be 0.42 μm. The Gaussian fitting result showed a full width at half maximum (FWHM) of 0.51 μm, indicating a submicrometer resolution, which is consistent with the calculated value.

To test the sensitivity, we measured the WPS signal at different thicknesses with fixed pump-probe delay (fig. S1C). We reached an SNR of 8 for 0.2% difference between cold and hot frames. The detection sensitivity can be further improved by coupling a thermal isolation layer to increase the photothermal signal (37).

To demonstrate the capability of imaging microparticles, we performed WPS imaging of 1-μm PMMA beads. The reflection image of beads on silicon wafer is shown in Fig. 4D. Although the magnification of the system was not well optimized for these small particles, the images still have sufficient pixels for each bead. The WPS imaging of the same area was acquired with the signal averaged for 0.5 s
(Fig. 4E). Individual beads were resolved at the PMMA C=O peak at 1728 cm⁻¹, while no contrast was shown at the off-resonance wavelength at 1808 cm⁻¹ (Fig. 4, E and F). Here, for consistency, we used the same camera settings for WPS imaging. Note that the field of view is only about a quarter of the previous “MIP” pattern in Fig. 4 (A to C), which potentially provides fourfold increase in imaging speed without any changes of the instruments.

**Ultrafast chemical mapping of a nanoscale film at the shot-noise limit**

We demonstrated widefield photothermal imaging of a thin PMMA film (486.89 ± 0.16 nm) and evaluated the SNR as a function of imaging speed (Fig. 5). A total of 1054 frames was captured in 410 ms, i.e., 0.39-ms exposure time per frame, with a field of view of 136 μm by 108.8 μm. This results in a WPS imaging speed of 1250 frames/s. For noise measurement, a reference experiment was performed, with the pump turned off. Therefore, the subtracted results were pure noise from the camera and the probe photon fluctuation. The SNR was calculated from the center region (25 pixels) by the ratio of the mean difference between the signal and reference to the SD of the noise. Figure 5A shows a single frame from the time trace, with the SNR calculated to be 2.3. Notably, the single-frame chemical image was based on only eight IR pump pulses. To further improve SNR, frame averaging was used as a trade-off of imaging speed (Fig. 5, B to E). We measured and calculated the SNR of each frame and fitted the results with a power function (Fig. 5F). The solid curve was the fitting result of different accumulating frames. The exponent term was 0.48, close to the theoretical limit of 0.5, indicating that the setup has been optimized for working near shot-noise limit. A video with an imaging speed of 1250 frames/s is available (movie S2). The signal intensities were relatively stable during the 0.42-s recording period, implying no sign of sample damage or photobleaching.

**Widefield photothermal imaging of living cells**

To demonstrate the capability of our WPS microscope for biological samples, we performed WPS imaging of living SKOV3 human ovarian cancer cells. Figure 6A shows the reflection bright-field image. The dark spots around the nucleus were confirmed to be lipid droplets by the WPS image at 1744 cm⁻¹ corresponding to the C=O bond in triglyceride (Fig. 6B). The individual droplets colocalized with the reflection image, and no obvious signal showed up at the nuclei area. By tuning IR to 1656 cm⁻¹ of the protein amide I band, the protein contents gave the contrast shown in Fig. 6C. The proteins are more uniformly distributed in the cells compared to the lipid droplets. Note that there is some residual absorption of water at this wavelength, which was not observed as no contrast was found in the medium region outside the cell. It is consistent with the previous study (19). This lack of contrast from water is due to the large heat capacity of water, resulting in a minimal change in temperature. Consequently, when we tuned IR to off-resonance at 1808 cm⁻¹, no contrasts were observed (Fig. 6D). For consistency with the instrument, we used the same field of view for cell imaging at a speed of 2 Hz. The final images were cropped to 40 μm by 40 μm for better visualization. Because of the phase-sensitive characteristic in interference detection, the depth-resolved capability can be achieved. Depth-resolved imaging of lipid droplets inside the same cell is shown in fig. S2. To validate the function between contrasts and axial positions, more depth positions will be acquired in the future experiments. Together, these data highlight the capability of imaging chemical components inside living cells with high speed.

**DISCUSSION**

We demonstrated a WPS microscope that probes the thermal-induced reflectivity change with a camera through virtual lock-in detection. The time-resolved mapping of heat dissipation was made possible by synchronization of frame capture with modulated IR pump and pulsed visible probe. Given the results of submicrosecond temporal resolution, ultrafast chemical imaging speed (up to 1250 frames/s), and submicrometer spatial resolution, our method opens a new way to study highly dynamic processes with motion blur–free observation. It also opens a door for reagent-free, high-throughput screening for...
fields ranging from pharmaceutical industry to cell biology (38–40). Another potential application is IR chemical histology at a submicrometer spatial resolution.

It is interesting to compare the imaging speed of the presented work to the previously demonstrated point-scan MIP imaging (19, 28) with the same SNR. Many factors are involved in these processes, which makes it difficult for a direct comparison. For instance, the photodiodes used in point-scan setup receive a lot more photons than a single pixel in the widefield CMOS (complementary metal-oxide semiconductor) camera, which, however, has a spatial multiplexing capability. Meanwhile, the pulsed probe in WPS maximizes the detection efficiency compared to the continuous-wave probe used in point-scan setup, where signal duration is much shorter than the modulation period. For a rough estimation, the SNR of a single pixel/photodiode is proportional to

$$\sigma \xi I_{IR} \sqrt{I_{pr}}$$  \(2\)

where $\sigma$ is the absorption cross section of a sample; $\xi$ is the detection efficiency, which is signal duration divided by probe beam duration; $I_{IR}$ is the IR power density at the sample; and $I_{pr}$ is the probe power density. Therefore, compared to the point-scan MIP, $\xi$ is the same. $\xi$ is 10 times higher. Because in WPS pulse duration matches the signal duration (~1 μs; Fig. 3B) in a hot frame, efficiency is 100%. Meanwhile in MIP, the detection period is 10 μs; therefore, $\xi$ is about 10%. $I_{IR}$ is about 2.5 times higher, given that IR focal spot is 2 times larger in diameter and IR power is 10 times higher. $I_{pr}$ is about 1 million times less. Plugging in the numbers, the SNR of a single pixel in WPS is about $1/40$ of that in MIP; therefore, 1600 frames are needed to achieve the same SNR. Now, consider the multiplex advantage in WPS, for a 200 pixel−by−200 pixel image, the imaging speed is about 25 times faster than the point-scan method. Experimentally, the pixel dwell time for point-scan was set to 0.5 to 1 ms for cancer cells (19) and 30 ms for particle samples (28), leading to more than 20 s per frame with 200 pixel by 200 pixel. In this work, we achieved good SNR for living cell imaging at a speed of 0.5 s per frame, which is 40 times faster and consistent with our estimations.

There is still plenty of room to improve the performance of the WPS system. The imaging speed can be further improved by using a camera with high well depth pixels. Because the WPS signal comes from small AC signals on top of a strong DC background, increasing the full well capacity of the image sensor helps to reduce the averaging time. The current camera provides a dynamic range of 58 dB with a full well capacity of 19 ke− and dark noise of 23 e−. As an example, the commercial camera (Q-2HF-W-CXP, Adimec) has 2 million full well capacity and 63-dB dynamic range, which can increase the speed by 10 times while maintaining the same SNR level. Furthermore, denoising methods (41) can be applied to further remove the noise in the X-Y-t or X-Y-λ data cube.

In addition, one can further increase the detection efficiency by using IR lasers with higher repetition rates. Increasing the repetition rate of the IR pump laser could minimize the duration of cold states, thus increasing the detection efficiency. In this work, the IR pump laser with a fixed repetition rate of 20 kHz and the camera with highest frame rate of 2500 frames/s were used. The thermal decay time constant was found to be 1.1 μs for a 486-nm-thick PMMA film on a silicon wafer substrate. The decay constant would be even shorter for nanoparticle specimens. Therefore, much room is available for an increased repetition rate, given a camera with comparable frame rate.

To increase the field of view, the IR focal spot size can be enlarged using longer focal length optics. The current field of view was around 36 μm by 36 μm with the CaF$_2$ lens of 20-mm focal length. If a lens with a focal length of 40 mm is used, the field of view could increase four times. More powerful IR lasers should be considered to compensate the power density reduction induced by the IR spot size increase.

The current study used counter-propagation of visible and IR beams. To broaden the applications, a co-propagation scheme can be developed, where the IR and visible beam travel toward the same direction, leaving space for thick samples. Previous work in backward-detected MIP (21) has demonstrated the implementation of co-propagation with the IR and visible beam sharing the objective. Alternatively, oblique illumination of the IR beam can be used to separate the optical elements for IR and visible for better alignment.

Furthermore, it is of great importance to chemically image nanosized particles in a biological or pharmaceutical environment. For this purpose, rigorous designs of the substrate and the embedding medium are needed. The bilayered substrate of Si and SiO$_2$ structure has successfully been used in the interferometric reflectance imaging sensor to probe biomass accumulation and single virus (34, 42). Hence, by comparing the interference intensity at hot and cold states, biological nanoparticles with chemical specificity can be effectively mapped.

**MATERIALS AND METHODS**

**WPS microscope**

The pump source was provided with a mid-IR optical parametric oscillator (Firefly-LW, M Squared Lasers), tunable from 1175 to 1800 cm$^{-1}$ (8.51 to 5.56 μm), in the fingerprint region. A CaF$_2$ plate was used to pick off partial IR beam and sent to an MCT (PVCM-10.6, VIGO System) detector. Because the camera shutter speed cannot catch each single pulse, we added an optical chopper (MC2000B, Thorlabs) to modulate the pump IR pulses. The chopper was working at 1250 Hz with a duty cycle of 50%. To reduce the rise and fall time of pulses at the edge of chopper blade, a gold-coated off-axis parabolic mirror (OAPM) with a focal length of 101.6 mm was used to focus the pump beam at the blade. This focal length was selected for the moderate focal spot size and ease of adjustment, considering strong astigmatism if misaligned. Another OAPM with the same focal length was set up to collimate the IR beam. The modulated pump beam was guided with gold mirrors and then weakly focused on the sample using a CaF$_2$ meniscus lens with a focal length of 20 mm. The visible probe beam was provided by a high-power LED working under pulsed operation mode (UHP-T-SR, Prizmatix). Because of the transient nature of the thermal diffusion process, we pulsed the LED output at the submicrosecond level to obtain the time-resolved signal. The central wavelength of the LED is 450 nm, and the spectral width is 22.6 nm. The LED emitter was conjugated on the back focal plane of the objective (SLMPLN Olympus, 20×, NA 0.25; 440 Leica, 40×, NA 0.66) through a pair of 4f lenses and 50/50 plate beam splitter. The MIP pattern images were acquired using the 40× objective, and all other data presented were acquired using the 20× objective. The sample was illuminated with the parallel beam, and the field of view was 136 μm by 108.8 μm for the 20× objective. The sample-reflected light was collected with the same objective and traveled back through the beam splitter to be imaged on a CMOS (IL5, Fastec Imaging) with a tube lens system. The camera shutter speed was set to 2500 frames/s at the abovementioned field of view.
Film sample preparation
Double-side polished silicon wafers with a thickness of 100 μm (University Wafer) were used as the substrates in film and pattern imaging. The silicon wafers were cleaned through multiple steps of solvent rinse, in the sequence of toluene, acetone, isopropanol, and deionized water, followed by O₂ plasma (300 sccm O₂ flow rate, 300 W, and 15 min) before the spinning coating process. To fabricate the PMMA films, PMMA 950 A4 solution (MicroChem) was spin-coated onto the cleaned silicon wafer at a speed of 1000 to 4000 rpm/s for 45 s. After soft baking at 180°C for 5 min, the film thickness was measured with an ellipsometer (Rudolph AutoEL IV-NIR-II). To fabricate the pattern, PMMA 950 A4 solution was spin-coated onto the silicon wafer at a speed of 4000 rpm/s for 45 s to get the electron-beam resist layer. After soft baking at 180°C for 5 min, the MIP patterns were fabricated onto the PMMA layer with electron-beam lithography using a Zeiss Supra 40 VP scanning electron microscope equipped with an electron-beam blanker and through subsequent development with methyl isobutyl ketone/isopropanol solvent mix (1:3 in volume).

Thermal decay characterization
The pump-probe delay was premeasured with an oscilloscope and noted as the reference for follow-up experiments. The delay was tuned using the function generator marked with phase shift in degrees. The entire 360° cycle corresponds to the pump pulse period of 50 μs.

Living cell imaging
The SKOV3 cells were cultured on a double-polished silicon wafer for 24 hours. The cells were moved to the microscope for immediate imaging after washing off cell culture medium and rinsed two times with phosphate-buffered saline.

Data acquisition and image processing
The images were captured at a camera shutter speed of 2500 Hz with a sensor resolution of 400 pixel by 320 pixel. To maintain the image quality, a 12-bit raw tiff image type was selected. For the model in the listed experiments, an acquisition process of 5 s that would generate 12,500 frames equals 3.1-gigabyte data size. We took advantage of the local memory drives. The downloaded images were analyzed with ImageJ and custom-coded based on LabView (National Instruments).

SUPPLEMENTARY MATERIALS
Supplementary material for this article is available at http://advances.sciencemag.org/cgi/content/full/5/7/eaa7127/DC1
Section S1. Simulation and experimental results for film samples
Section S2. Estimation of maximum probe power saturating the camera sensor
Fig. S1. Simulation and experimental results for film samples.
Fig. S2. Widefield photothermal imaging of living cells at different depths.
Movie S1. Movie clip showing the time-resolved imaging of the transient thermal process of a 486-nm-thick polymer film.
Movie S2. Movie clip showing an ultrafast imaging speed of 1250 frames/s of a 486-nm-thick polymer film.

REFERENCES AND NOTES


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Data and materials availability: All data needed to evaluate the conclusions in the paper are present in the paper and/or the Supplementary Materials. Additional data related to this paper may be requested from the authors.

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